



PATENT

Case Docket No. MICRON.009DV1

Date: April 23, 1999

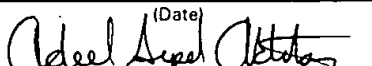
Page 1

In re application of : Schuegraf et al.
App. No. : 08/932,228
Filed : September 17, 1997
For : SHALLOW TRENCH
ISOLATION USING LOW
DIELECTRIC CONSTANT
INSULATOR
Examiner : H. Vu
Art Unit : 2811

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

April 26, 1999

(Date)

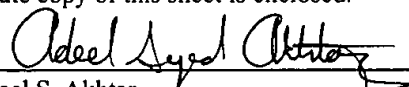

Adeel S. Akhtar/ Reg. No. 41,394

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

Sir:

Transmitted herewith in the above-identified application are the following:

- (X) Request for Withdrawal From Abandonment, including copies of a previously filed Amendment and Supplemental Information Disclosure Statement.
- (X) Replacement Supplemental Information Disclosure Statement.
- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410. A duplicate copy of this sheet is enclosed.


Adeel S. Akhtar
Registration No. 41,394
Attorney of Record

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TECHNOLOGY CENTER 2800

Appl. No. : 08/932,228
Filed : September 17, 1997

Enclosed is a copy of all the materials previously hand-delivered in the Patent Office, including a copy of the return postcard with the Patent Office Received stamp. Also enclosed is a copy of the Examiner Interview Summary Record signed by Examiner Hung Vu on the same day.

Please note that the information disclosure inadvertently included a certification under 37 CFR §1.97(e)(1), rather than §1.97(e)(2) as indicated in the first paragraph. Accordingly, a Replacement Supplemental Information Disclosure Statement is filed herewith, enclosing the originally cited Japanese patent.

Based on the foregoing, it is requested that the abandonment be withdrawn and that the prosecution of the application be completed. In view of the time lost since our September 16, 1998 response, it would be greatly appreciated if the matter received prompt attention. If the Examiner has any questions regarding this matter or with the merits of the enclosed response, the Examiner is cordially invited to call the undersigned.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: April 23, 1999

By: Adeel S. Akhtar

Adeel S. Akhtar
Registration No. 41,394
Attorney of Record
620 Newport Center Drive
Sixteenth Floor
Newport Beach, CA 92660
(415) 954-4114

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COT Y

UTILITY/DESIGN PATENT

DATE: 9-15-98

(amend/final amend)

DATE OF O.A.: 8-12-98

Rec'd in the U.S.P.T.O. on the date stamped hereon via Certificate of Mail:

Atty Dkt # MICRON.00901 A/N: 08/932,228 Filed: 9-17-97

Exr: VU Atty: JB/ASH Art Unit: 2871

Applicant(s): Schwegel et al.

Title: Shallow Trench Isolation Using Low

VERIFIED BY: Asst: L. Fuller Quality Control:

☐ Transmittal Sheet in dupl. ☒ Amendment in 4 pgs.

☐ Mo. Ext. of Time in dupl. ☐ Small Entity Statement(s)

☐ Req. for Drawing Changes, marked in RED ☐ Submission of Formal Drawings

 pgs of Drawings ☐ Transmittal

☒ Information Disclosure Statement; Supp. ☐ pgs of Formal Drawings

PTO-1449 w/ Refs. ☐ \$ Check for Amendment

☐ Issue Fee Transmittal in dupl. ☐ \$ RECEIVED Issue Fee Soft Copies

☐ ☐ SEP 16 1998

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☒ Return Postcard

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